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9780819439956 - Resolution Enhancement Techniques in Optical Lithography Spie Tutorial Texts in Optical Engineering Vol Tt47 by Alfred Kwok-kit Wong

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forcing semiconductor manufacturers to extend the current 193 nm optical lithography systems The combined techniques include Resolution Enhancement

Mutually Optimizing Resolution Enhancement Techniques: Illumination, APSM, Assist Feature OPC, and Gray Bars Proc. SPIE Optical Microlithography XIII,

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